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**PAPER** WooChul Jung *et al.* Robust nano-architectured composite thin films for a low-temperature solid oxide fuel cell cathode



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## 1. Introduction

Solid oxide fuel cells (SOFCs) have gained a considerable amount of attention as a promising next-generation power system due to their high energy conversion efficiency and fuel flexibility.1 The main issue with regard to SOFCs is their high operating temperature (700-1000 °C) and the resulting material and cost limitations and operating complexities.<sup>2</sup> In this regard, thin-film based, low-temperature solid oxide fuel cells (LT-SOFCs), manufactured using micro-fabrication techniques, have recently been investigated.<sup>3-7</sup> The thin film membrane, downscaled to several hundreds of nanometers, allows lower operating temperatures, e.g., less than 450 °C by reducing the ohmic resistance of a solid electrolyte (SE). This helps to solve the main technical issues associated with conventional SOFCs running at elevated temperatures. This approach also has the merits of rapid start-up and shutdown cycles and reduced system cost.<sup>2</sup>

As of now, the key challenge that has limited the development and deployment of LT-SOFCs is the lack of suitable

## Robust nano-architectured composite thin films for a low-temperature solid oxide fuel cell cathode<sup>†</sup>

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Thin-film based, low temperature solid oxide fuel cells (LT-SOFCs) have gained much attention due to their capability to reduce the operating temperature (<450 °C) and the ensuing extended life and reduced cost, compared to conventional SOFCs. While highly porous and continuously connected Pt thin films are viewed as an attractive cathode, they are readily apt to sinter and grow into larger, isolated crystallites upon annealing, leading to severe degradation of the cathode performance over time. Here, we address this issue by fabricating a post-encapsulated composite structure, in which gas-permeable and catalytically active solid electrolytes surround porous Pt electrodes. Nanoporous Pt thin films deposited onto a yttria-stabilized ZrO<sub>2</sub> (YSZ) single-crystal substrate are uniformly coated with Sm-doped CeO<sub>2</sub> (SDC) *via* a simple, cost-effective and scalable coating method known as cathodic electrochemical deposition (CELD). Physical characterization of the nanostructured Pt/SDC composite thin films is done using a range of tools, in this case SEM, TEM, XRD and ICP-MS. AC impedance spectroscopy (ACIS) of symmetric cells (cathode|electrolyte|cathode) with SDC coatings reveals that the enhanced Pt–SDC interactions led to exceptionally high ORR activity and outstanding thermal stability. These observations provide new directions for the achievement of a robust and catalytically active LT-SOFC cathode through modification of the metal surface.

cathode materials with the requisite combination of thermal and chemical stability, electrical conductivity and catalytic activity toward oxygen reduction reaction (ORR). While perovskite-based conducting oxides such as (La,Sr)MnO<sub>3</sub>, (La,Sr) (Co,Fe)O<sub>3</sub> and (Ba,Sr)(Co,Fe)O<sub>3</sub> are widely used as cathode materials for the conventional SOFCs, the poor ORR activity at reduced temperatures (<450 °C) and the ensuing large cathodic polarization resistance significantly hinder their utilization for LT-SOFCs.<sup>8-11</sup> Moreover, the use of such multi-component oxides typically requires a high-temperature sintering process to obtain a single-phase crystallite, which may lead to thermomechanical failures in thin-film components, particularly when the fabrication protocols are not carefully controlled.

In this regard, platinum (Pt) is viewed as an attractive choice as a cathode material due to its process compatibility with micro-fabrication techniques, excellent ORR activity, and good electronic conductivity. Furthermore, in contrast to other metals (*e.g.*, Ni, Al, Cu), Pt has excellent great oxidation tolerance in air, with none of its oxides (*e.g.*, amorphous PtO<sub>x</sub>, PtO and PtO<sub>2</sub>) known to be thermodynamically stable above 350 °C.<sup>12,13</sup> For these reasons, despite the high cost of Pt, essentially most successful demonstrations in the literature of thin-film based LT-SOFCs, where success is defined as a peak power density ranging from several tens to several hundreds of milliwatts per cm<sup>2</sup> at around 400 °C, involve Pt thin films as an electrode.<sup>14-18</sup> Considering that the ORR at SOFC cathodes is



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#### Paper

generally assumed to take place only within a limited region near the triple phase boundary (TPB), where the electronic conductor, the ion conductor, and the gas phase are in simultaneous contact, it is necessary to fabricate a highly porous but interconnected Pt structure with a high site density of TPBs. However, porous nanoscale Pt films are apt to sinter and grow into larger, isolated crystallites upon annealing, leading to a severe loss of catalytic activity and current collecting ability.<sup>19–24</sup> Thus, the poor thermal stability of nanoporous Pt film limits its technical application to LT-SOFCs.

Here, we address this issue by fabricating a post-encapsulated composite structure, in which gas-permeable and catalytically active SE layers surround porous Pt films. This electrode structure enables the achievement of decent longterm durability with exceptionally high kinetic performance as LT-SOFC cathodes. There have been several reports in the literature regarding Pt/SE composite thin film electrodes, where SE oxide serves as a physical protection layer against Pt agglomeration and/or an oxygen ion current pathway so as to maximize the TPB site density. For example, Buyukaksoy et al. attempted to coat the surfaces of Pt thin film electrodes by the infiltration of yttria-stabilized ZrO<sub>2</sub> (YSZ), showing improved thermal stability at extremely high temperatures (>800 °C) for over 200 h.25 On the other hand, Hertz et al. fabricated nanocomposite Pt/YSZ thin film electrodes by means of magnetron co-sputtering, exhibiting an area-specific resistance (ASR) of the resulting composite films of less than 500  $\Omega$  cm<sup>2</sup> at 400 °C.<sup>26</sup> Chang et al. also reported an enhanced power density by 2.5 times through the application of ALD-coated thin YSZ layers onto porous Pt electrodes.<sup>24</sup> It should be noted, however, that most relevant studies focused only on Pt/YSZ composite structures, and the fabrication methods employed appear tedious and costly. Given that acceptor-doped  $CeO_2$  (ceria) has higher ionic conductivity and more favorable catalytic activity for ORR<sup>27-29</sup> as compared to YSZ, the combination of Pt and ceria may be feasible for a high-performance SOFC cathode. To the best of our knowledge, however, very few studies have made an attempt to fabricate Pt/ceria composites,30 which fewer yet utilizing this combination in LT-SOFCs.

In this work, nanoporous Pt thin films deposited onto a YSZ single-crystal substrate are coated with Sm-doped CeO<sub>2</sub> (SDC) via a simple, cost-effective and scalable coating method known as cathodic electrochemical deposition (CELD). While it is widely used for various industrial applications, CELD has rarely been investigated as a manufacturing tool for SOFC electrodes. In previous work, we demonstrated that the Ni-surface modification of SDC layers via CELD showed remarkably enhanced activity toward the fuel oxidation reaction and carbon coking stability as a SOFC anode.<sup>31</sup> As continuing work, we apply this coating method to achieve a robust and high-performance LT-SOFC cathode. Electron microscopy reveals that nanostructured SDC layers are uniformly coated onto both surfaces of a Pt electrode and a YSZ SE. The electrochemical characteristics of the composite films were investigated via AC impedance spectroscopy (ACIS) as a function of the deposit time, temperature and oxygen partial pressure. The enhanced Pt-SDC interactions lead to exceptionally high ORR activity and outstanding thermal

stability. We show that a CELD treatment of only 5 min creates an oxide coating that increases the electrode conductance by more than two orders of magnitude compared to a bare Pt electrode, while also simultaneously maintaining the conductance level for more than 100 h at 600  $^{\circ}$ C without any degradation.

## 2. Experimental

#### 2.1 Fabrication of nanoporous Pt thin films

Highly porous and interconnected Pt thin films with a thickness of 100 nm were fabricated on both (100) single-crystal YSZ (8 mol%,  $10 \times 10 \times 0.5$  mm<sup>3</sup>, MTI Corp.) and (100) single-crystal Si ( $10 \times 10 \times 0.5$  mm<sup>3</sup>, Siltron) substrates by means of oxygen reactive DC magnetron sputtering. The sputtering system was operated with a three-inch Pt target (99.98%, Wooilmetal) at a DC power of 50 W in a mixed argon and oxygen atmosphere (Ar/O<sub>2</sub> = 1), while maintaining a working pressure of 10 mTorr. After the reactive sputtering process, we decomposed the asdeposited PtO<sub>x</sub> films by quickly putting them into a tube furnace, which had been maintained at 600 °C in air. And after heat treatment for 1 h, they were quenched to room temperature (RT) and finally porous Pt nanostructures were obtained.<sup>32</sup>

#### 2.2 Electrochemical deposition of $Sm_{0.16}Ce_{0.84}O_{1.92-\delta}$ films

An aqueous electrolyte solution was prepared with nitrate-based cation precursors, Ce(NO<sub>3</sub>)<sub>3</sub>·6H<sub>2</sub>O and Sm(NO<sub>3</sub>)<sub>3</sub>·6H<sub>2</sub>O, (99.99%, Alfa Aesar) and then saturated with  $O_2$  gas with a flow rate of 300 sccm for 30 min. Cation molar concentrations of 0.0475 M and 0.0025 M for Ce<sup>3+</sup> and Sm<sup>3+</sup>, respectively, were chosen to create the resulting coating layer of Sm<sub>0.16</sub>Ce<sub>0.84</sub>O<sub>1.92-\delta</sub>. A traditional three-electrode cell was used with a standard calomel electrode (SCE, +0.24 V vs. SHE, Koslow) for a reference electrode, and a carbon rod was used as a counter (anodic) electrode. Electrical contact with the porous Pt films, deposited on both sides of a YSZ substrate, was made using tailor-made aluminum clips, which served as a working electrode. Electrochemical deposition was conducted at room temperature in the potentiostat mode, in which a fixed electric potential of -0.7 V (vs. SCE) between the working electrode and the reference electrode was applied and the resulting current from the counter electrode to the working electrode was measured. The deposition time varied from 15 s to 15 min.

#### 2.3 Physical characterization of Pt/SDC composite films

The microstructures of both bare and CELD-coated Pt films were examined by scanning electron microscopy (SEM, Hitachi S-4800). The pore size and TPB density of the bare Pt films were estimated through an image analysis using ImageJ software (U.S. National Institutes of Health, 1.48v). Transmission electron microscopy (TEM, 300 kV-Tecnai G2 F30 S-Twin) was used for close monitoring of the interfaces in the vicinity of the TPBs, and the elemental compositions of the Pt/SDC films were linescanned using energy-dispersive X-ray spectroscopy (EDX). An inductively coupled plasma mass spectrometry (ICP-MS, Agilent IPC-MS 7700S) analysis was undertaken with a mixture of nitric

and hydrochloric acid (7 : 3) at 200 °C for 30 min by microwave digestion to measure the chemical composition of the coated SDC layers precisely. X-ray diffraction (XRD, Rigaku Ultima IV) with Cu-K $\alpha$  radiation ( $\lambda = 1.5418$  Å) at 40 kV and 40 mA with a scan rate of 4° per min from 20° to 60° was used to identify the crystal structures of the films.

#### 2.4 Electrochemical analysis

A symmetric cell structure with identically sized  $(10 \times 10 \text{ mm}^2)$ bare and CELD-coated Pt electrodes on both sides of the YSZ electrolyte was used for AC impedance spectroscopy (ACIS, VSP-300, Biologic) measurements. AC amplitude of 20 mV at a frequency range of 4 mHz to 2 MHz was used. The perturbation voltage of 20 mV was chosen in this work so as to lie within the linear regime of the sample's current-voltage response. The cells were placed inside a continuous-flow alumina tube into which mixtures of O2 and Ar were delivered via digital mass flow controllers. The total flow rate was kept constant at 100 sccm (standard temperature and pressure), implying a gas velocity of 19.7 cm min<sup>-1</sup>. Impedance measurements were carried out at temperatures between 300 and 450 °C and at an oxygen partial pressure between 0.05 and 1 atm. Fig. S1<sup>†</sup> shows a detailed temperature profile of the measurements. The long-term stability of bare Pt and CELD-coated Pt electrodes was then evaluated at 600 °C and 0.21 atm O<sub>2</sub> for 40 h and 100 h, respectively.

### 3. Results and discussion

#### 3.1 Overall fabrication processes

Fig. 1 describes the entire fabrication process used to obtain the Pt/SDC composite films. It involves the formation of nanoporous Pt films by the thermal decomposition of Pt oxidic compounds (PtO<sub>x</sub>) followed by the deposition of SDC layers onto them. The porous Pt structure was obtained when meta-stable  $PtO_x$  formed under  $Ar/O_2$  plasma conditions and was then reduced upon a heat treatment. The resulting films exhibited percolating Pt networks infiltrated with interconnected nano-sized pores,

After decomposition, the nanoporous Pt films served as a working electrode for the subsequent electrochemical deposition of ceria. A description of the deposition of ceria films by CELD is available in the literature.<sup>33,34</sup> In short, the CELD process involves three steps: (1) the electro-generation of hydroxyl ions  $(OH^{-})$  by the reduction of species such as  $H_2O, O_2$ ,  $H^+$  or  $NO_3^-$  at the Pt working electrode, (2) the chemical precipitation of Ce(OH)3 through an increase in the solution pH in the vicinity of the Pt electrode, and (3) the complete oxidation of hydrate to form CeO<sub>2</sub> upon dry and/or annealing. Given that the thermodynamic stability of Sm is similar to that of Ce (e.g., Pourbaix diagrams of both Ce-H<sub>2</sub>O and Sm-H<sub>2</sub>O are nearly identical.35), one can expect Sm to be incorporated into ceria films by the same mechanism during the electrochemical deposition step. The important point here is that the SDC coating layers must serve as an ionic current pathway to maximize the TPB site density and as a physical protector against Pt agglomeration. Accordingly, the deposited layers must ensure simultaneous contact between the Pt electrode and the YSZ electrolyte while maintaining sufficient oxygen gas accessibility. In contrast to metal electrodeposition, in which a cationic species is reduced to an insoluble metallic form directly on a growing film, CELD involves oxide precipitation reactions within a solution phase. Hence, the process can be used to coat the surfaces of composite anode structures in which both electronically insulating and electronically conductive phases are present.<sup>31,34</sup> The targeted structure of the composite film in this work is shown in Fig. 1 (bottom images) with the maximum number of TPBs.

#### 3.2 Physical and chemical characterization

Fig. 2 exhibits SEM images of both bare and CELD-coated Pt films as a function of the deposition time. The bare Pt film



Fig. 1 Schematic diagram of the overall fabrication procedures (top) and the targeted structure of composite films in this work, compared to bare Pt (bottom). SDC:  $Sm_{0.16}Ce_{0.84}O_{1.92-\delta}$ .

#### Paper

provided a highly porous and continuously connected geometry, comparable to those of other Pt electrodes for LT-SOFCs in literatures, with an estimated pore size of 45  $\pm$  24 nm and a TPB density of 15  $\mu$ m  $\mu$ m<sup>-2</sup> according to the SEM image analysis.<sup>18,36,37</sup> This nanoporous Pt film structure serves as a simple platform on which to evaluate the impacts of CELD coating layers on the cathode performance. With the electrochemical deposition, the Pt films are uniformly covered by a dark layer which infiltrates into the nanoscale pores in the Pt network. As the deposition time increases, the CELD-coating layers thickens, eventually covering the entire Pt surface (Fig. 2(b)-(d) and (f)-(h)). Only 1 min of deposition creates coating layers sufficiently thick to observe a reduction in the pore size visually compared to the bare Pt films. Cross-sectional SEM images showed that the layer thicknesses are 21  $\pm$  4 and 76  $\pm$  13 nm for deposition times of 3 and 5 min, respectively. It should be noted that the deposited SDC films typically exhibit nano/micro-scale cracks due to the volume change when transforming from a hydrated cerium oxy-hydroxide to CeO<sub>2</sub> or to the possible shrinkage of ceria,34,38 conceivably facilitating gas-phase diffusion through the SDC film as well. Upon annealing at 450 °C in air for 10 h, the SDC film becomes more porous, with nano-scale cracks, compared to an as-deposited film, as shown in Fig. S2.† Importantly, the coated layers make simultaneous contact between the Pt electrode and the YSZ substrate, enabling continuous ionic current flows from the YSZ electrolyte through the layers. Furthermore, as discussed later, this structure prevents the pre-deposited Pt films from sintering.

The chemical composition of the deposits, analyzed by ICP-MS, shows that the concentration of Sm in the film is about 16%, which is higher than that of the starting solution (5%), as shown in Table 1. This behaviour may stem from that fact that the standard reduction potential of  $Ce^{3+}$  is more negative than that of Sm<sup>3+ 39</sup> or from the fact that Sm(OH)<sub>3</sub> is less soluble than  $Ce(OH)_3$ .<sup>40</sup> XRD patterns of both the bare and the CELD-coated Pt films are presented in Fig. 3. Here, to avoid shadow effects from a substantially large YSZ (100) peak in the single-crystal substrate, the composite film was fabricated on a Si (100) substrate. The CELD-coated layer, after annealing at 600 °C for

Table 1 ICP-MS composition analysis of CELD-coated SDC films, deposited at applied potential of -0.7 V vs. SCE for deposition time of 10 min

Sample	Concentration of Ce, ppm	Concentration of Sm, ppm	Atomic percent of Sm, at%
-0.7 V, 10 min	585.1	116.9	15.7

10 h in air, shows only a cubic fluorite structure without any secondary phase, indicating that  $\text{Sm}_{0.16}\text{Ce}_{0.84}\text{O}_{1.92-\delta}$  is the primary phase in this work. The calculated value of the lattice constant of the SDC film is 5.427 Å, which as in good agreement with the reported value of 5.427 Å for  $\text{Sm}_{0.15}\text{Ce}_{0.85}\text{O}_{1.925-\delta}$ .<sup>41</sup> This, in fact, is the most widely used composition of ceria in SOFCs.

The atomic-scale features of the YSZ|SDC and Pt|SDC interfaces are shown in Fig. 4. The SDC layers, grown at -0.7 V for 5 min, are uniformly coated onto the Pt surfaces (Fig. 4(a)),



Fig. 3 X-ray patterns of bare and CELD-coated Pt films on a (100) single-crystal Si substrate after annealing at 600  $^\circ$ C for 10 h in air.



Fig. 2 Top-view and cross-section SEM images of CELD-coated Pt films on a YSZ single-crystal substrate at applied potential of -0.7 V vs. SCE as a function of the deposition time; (a) and (e) for bare Pt (0 s), (b) and (f) for 1 min, (c) and (g) for 3 min, (d) and (h) for 5 min.

providing a good match to the line scan profile data (Fig. 4(c)). The imaged regions indicate good contact, suggesting easy transport of ionic species between the two oxides and ready electron transfer from the Pt phases to the Pt|SDC interfaces, as shown in Fig. 4(b). As discussed later in more details, these features are essential for expanding the active reaction sites from Pt|YSZ|air to Pt|SDC|air.

#### 3.3 AC impedance spectroscopy

Journal of Materials Chemistry A

Selected AC impedance results obtained at 375 °C with  $pO_2 =$ 0.21 atm are presented in Fig. 5. The raw impedance spectra for symmetric cells including both bare and CELD-coated Pt electrodes generally showed two adjacent semicircles, which are distinguished as a nearly ideal high-frequency (HF) and a slightly distorted low-frequency (LF) semicircle, respectively. While the HF arc remains nearly identical for all samples regardless of the CELD treatment, the LF arc decreases substantially after the SDC layers are coated onto the Pt electrodes. These impedance spectra were modelled by a series of two parallel RC sub-circuits. More generally, the capacitor was replaced by a constant phase element (CPE), for which the overall impedance was determined by  $Z_Q = 1/Q(i\omega)^n$ . The effective capacitance could be extracted from the expression, C  $= (R^{1-n}Q)^{1/n}$ . Several features of the HF impedance spectra are consistent with the source being the bulk impedance of the YSZ electrolyte single-crystal substrate. These include the activation energy of resistance of 1 eV and its  $pO_2$  independence. Furthermore, the magnitude of both the conductivity (1.2  $\times$  $10^{-5}$  S cm<sup>-1</sup> at 350 °C) and dielectric constant (47–66 at T =300-450 °C), calculated based on the present cell geometry and measured values of R and C, are in good agreement with the literature data for YSZ ( $3.1 \times 10^{-5}$  S cm<sup>-1</sup> and 60 at 350 °C).<sup>42</sup> This is also supported by the fact that the CELD coating does not change the HF impedance spectra.

Accordingly, the remaining LF spectra are attributed to the electrode response. The *R* and *C* values derived from this part of the impedance spectra are designated as  $R_{\text{electrode}}$  and  $C_{\text{electrode}}$ , respectively. The dependences of the resistance terms of both the bare and CELD-coated Pt electrodes on the temperature and



**Fig. 5** Typical impedance spectra of bare (black) and CELD-coated Pt (blue) electrodes on both sides of a YSZ single-crystal electrolyte measured at 375 °C with  $pO_2 = 0.21$  atm. A magnified semicircle of CELD-coated Pt electrode at low-frequency is indicated. The impedance spectra were modelled by a series of two parallel RC sub-circuits (insert). Solid line: the fitting results.

oxygen partial pressure are summarized in Fig. 6. Here, as an indicator of the electrode activity toward the ORR, the values of the electrode conductance normalized with regard to the nominal electrode area were used. In general, the electrode conductance of both the bare and CELD-coated Pt films increases with the temperature with a linear slope in an Arrhenius plot, typical electrode behaviour when thermally activated processes are involved. Here, two factors should be mentioned. First, the electrode conductance increased substantially when the SDC layers are coated. For example, a CELD treatment of only 5 min creates an oxide coating that increases the values of the electrode conductance by more than two orders of magnitude compared to a bare Pt electrode. This implies that modification of the Pt surface by CELD is highly favorable for the ORR, suggesting it as a suitable method to enhance the kinetic performance of LT-SOFC cathodes. Second, despite the significant difference in the magnitudes of the



Fig. 4 Cross-section TEM images of (a) CELD-coated Pt films deposited at applied potential of -0.7 V vs. SCE for 5 min, (b) an atomic-scale feature of the YSZ|SDC and Pt|SDC interfaces and (c) a line scan profile at Pt|SDC interface (the yellow arrow marked in (a)).



Fig. 6 (a) Temperature and (b)  $pO_2$  dependences of the electrode conductance values of CELD-coated Pt electrodes as a function of deposition time (0–15 min).

conductance levels between the bare and the coated films, they show nearly identical activation energy and  $pO_2$  dependence values within a reasonable amount of error (<7%). Table 2 summarizes the dependences of the electrode conductance on the temperature and  $pO_2$  as a function of the deposition time. The values of the activation energy range from 1.16 to 1.36 eV for all deposition times (0–15 min) at T = 300-450 °C and  $pO_2 =$ 0.21 atm. Furthermore, the power-law dependence,  $pO_2^m$ , of the electrode conductance on the oxygen partial pressure exhibits similar *m* values between 0.27 and 0.40. These observations indicate that the dominant reaction sites in all cases are identical, likely attributable to the TPBs between Pt, SE and air. Accordingly, the different conductance levels among the samples are considered to be the result of the differing TPB site density levels.

Focusing on the coated samples, the electrode conductance increases considerably with the deposition time (and thereby the deposited thickness) during the initial 5 min of deposition (see Fig. S3<sup>†</sup> for the detailed relationship between the deposition time and film thickness). However, the electrode conductance levels remain relatively constant after reaching a maximum value at a deposition time of 5 min (Fig. 7(a)). The increase in the conductance is attributed to the fact that the number of percolated SDC nanoparticles in the vicinity of Pt and YSZ tended to increase over time, leading to an extension in

Table 2 Dependences of the electrode conductance on temperature and  $pO_2$  as a function of the deposition time (0–15 min)

Deposition time, s	Activation energy $(E_a)$ , eV	<i>p</i> O <sub>2</sub> dependence
0	$1.36\pm0.08$	$0.29\pm0.03$
60	$1.16\pm0.04$	$0.27\pm0.01$
180	$1.29\pm0.02$	$0.36\pm0.02$
300	$1.32\pm0.02$	$0.37\pm0.01$
600	$1.30\pm0.02$	$0.40\pm0.01$
900	$1.34\pm0.02$	$0.36\pm0.01$
0 60 180 300 600 900	$\begin{array}{l} 1.36 \pm 0.08 \\ 1.16 \pm 0.04 \\ 1.29 \pm 0.02 \\ 1.32 \pm 0.02 \\ 1.30 \pm 0.02 \\ 1.34 \pm 0.02 \end{array}$	$\begin{array}{l} 0.29 \pm 0.03 \\ 0.27 \pm 0.01 \\ 0.36 \pm 0.02 \\ 0.37 \pm 0.01 \\ 0.40 \pm 0.01 \\ 0.36 \pm 0.01 \end{array}$

the number of active reaction sites from Pt|YSZ|air to Pt|SDC| air. On the other hand, upon a longer deposition time (>5 min), the porous Pt surfaces are sufficiently covered by SDC layers without a further increase in the number of TPB sites. One may expect that thicker SDC coating layers inhibit oxygen gas-phase diffusion, but this is not observed, confirming that the nano/ micro-scale cracks which form during the drying and/or annealing processes provided sufficient gas permeability in the composite films.

Turning to the capacitive part of the electrode impedances, all sample show typical double-layer capacitance behavior with reference to magnitude ( $\sim 10^{-4}$  F cm<sup>-2</sup>) and  $pO_2$  independence.<sup>43,44</sup> Interestingly, the magnitude of  $C_{\text{electrode}}$  also increases with the deposition time, reaching a stable value when it exceeds 5 min, as in the case for  $R_{\text{electrode}}$  (Fig. 7(b)). This behavior indicates that electrochemically active interface area increases upon SDC deposition, strongly supporting the previous conclusion that the ORR active reaction sites, TPBs, extend from Pt|YSZ|air to Pt|SDC|air.

While the detailed reaction mechanisms of the ORR on the Pt/SE composite electrodes remain not fully understood, several elemental processes have been suggested as the acceptable ratedetermining step (RDS).9,45-49 These typically include (1) the adsorption/dissociation of  $O_2$  involving an electron transfer, (2) the surface diffusion of adsorbed oxygen species on Pt surface to the TPBs, and (3) the incorporation of oxygen species into the SE lattice near the TPBs. If the first process (1) is RDS in this work, the ORR rate must then increase with the exposed surface area of Pt, resulting in a decrease in the total electrode conductance caused by the CELD coating because the SDC deposits partly cover the Pt surfaces. Accordingly, the possibility that process (1) is the RDS is eliminated. To narrow down the dominant process governing the ORR activity in the composite electrodes, we inserted a dense interlayer of SDC with a thickness of 200 nm by pulsed layer deposition (PLD) in between YSZ and Pt and analyzed the impedance results as a function of the temperature and  $pO_2$  (see Fig. S4<sup>†</sup>). This was done to convert the dominant reaction sites from Pt|YSZ|air to Pt|SDC|air, so as to



Fig. 7 The values of (a) electrode conductance and (b) capacitance of CELD-coated Pt electrodes as a function of deposition time (0-15 min).

observe the role of the SE composition on the ORR activity. In fact, we find that both Pt|YSZ|Pt and Pt|SDC|YSZ|SDC|Pt cells exhibit nearly identical values of  $R_{\text{electrode}}$ ,  $E_{\text{a}}$  and the  $pO_2$ power dependence, as shown in Fig. S5.† Such independence of the electrode impedance on the SE composition likely indicates that process (3) is not the RDS, but (2) is in this work. Because the effective diffusion lengths from the Pt surface to the TPB (Pt|SDC|air) of the CELD-coated Pt electrodes are expected to be shorter than that of the bare Pt electrodes, the increase in the electrode conductance upon the CELD treatment can be explained. This is also supported by earlier work. For example, Wang et al. reported that the slow surface diffusion of oxygen could govern the electrode conductance with an activation energy  $(E_a)$  in the range of 1.1–1.3 eV and  $pO_2$  dependence (m) of 3/8, where *m* is defined as a power-law dependence,  $pO_2^m$ , of electrode conductance, which are comparable to our results (Ea values of 1.16-1.36 eV and m values of 0.27-0.40, respectively), at 500 °C in Pt electrodes on solid electrolyte.49,50 These similar values may support the important role of oxygen diffusion on top of Pt electrodes regarding the overall electrode conductance levels. However, it should be noted that the possible role of SDC itself in catalysing cathode reactions should not be perfectly eliminated in our study due to inherent activity of ceria toward ORR. Fig. S6<sup>†</sup> shows the reported activities of ceria and other materials as a function of the temperature, in which the activity is defined by the surface oxygen exchange coefficient  $(k_s)$ . In fact, ceria is as active as (La,Sr)(Co,Fe)O<sub>3</sub> - a state-of-the-art SOFC cathode. Further investigation regarding the detailed ORR mechanism on the composite electrodes will be needed.

#### 3.4 Long-term stability

Of potentially greater importance than the initial performance, particularly for a nanostructured component intended to be utilized at high temperatures for long periods of time, is the retention of the activity during the prolonged exposure to operational conditions. In this regard, the long-term durability levels of both the bare and the CELD-coated (deposition time = 5 min) Pt electrodes were tested at 600 °C, as shown in Fig. 8(a) and (b),

respectively. A temperature of 600 °C was chosen for this assessment to accelerate the agglomeration of Pt films,<sup>22</sup> although the targeted operation temperature in this study is less than 450 °C. Temperatures higher than 600 °C were not used, given that the goal of this study was to find a process compatible with typical micro-fabrication schemes that operate under restricted thermal budgets. The stability of the CELD-coated Pt is exceptional. Whereas the bare Pt shows a dramatic increase in both the HF and LF resistance levels, the CELD films display nearly constant resistance levels for more than 100 h (Fig. 8). After only 40 h of annealing, SEM reveals that the bare Pt film is considerably sintered, thus forming isolated particles and thereby disconnecting the lateral current flows (see Fig. S7<sup>†</sup>). This may be why the HF impedance, which was originally attributed to the bulk resistance of the YSZ electrolyte, increases over time, as the disconnected Pt film reduces the active cross-sectional area for the electrochemical cells effectively. On the other hand, the CELD-coated films exhibit outstanding long-term stability while maintaining nearly constant levels of both the HF and LF resistance over time (Fig. 8(c) and (d)). The enhanced thermal stability of the CELD-coated Pt films can be attributed to the existence of SDC deposits, which may serve as a physical shielding layer from Pt agglomeration, as expected. Furthermore, several rear-earth oxides are known to form a strong bond with precious metals under oxidizing conditions, thereby giving rise to high sintering resistance.<sup>22,51</sup> For example, Nagai et al. reported that Pt particles on ceria-based oxides form robust Pt-O-Ce bonds, serving as an anchor and thereby significantly hindering the agglomeration of Pt particles at even 800 °C as compared to those on alumina.51 Therefore, one can conclude that the Pt-SDC interactions enhanced by the CELD treatment lead to robust LT-SOFC cathodes.

Lastly, the material cost of Pt needs to be mentioned. We estimated the amount of Pt loading used in our work and compared this value with the 2020 target value from the Department of Energy (DOE) for proton exchange membrane fuel cells (PEMFCs).<sup>32</sup> By assuming 30% porosity of the Pt thin films used in this work, the amount of Pt loading is calculated to be 0.150 mg cm<sup>-2</sup>, while the DOE target value is 0.125 mg cm<sup>-2</sup>. Therefore, one can say that the amount of Pt loading involved in this work is small enough such that there will be no significant impact on the cost.



**Fig. 8** Changes in the typical impedance spectra of (a) bare and (b) CELD-coated Pt electrodes over time (at 600 °C with  $pO_2 = 0.21$  atm for 40 h and 100 h, respectively). The time-dependent resistance levels of (c) high-frequency and (d) low-frequency impedance spectra obtained from samples with bare (black) and CELD-coated Pt (blue) films.

## 4. Conclusions

Nanostructured precipitates of SDC are uniformly coated onto porous Pt thin films via a simple, cost-effective and scalable coating method known as CELD in an effort to realize a thermally stable composite cathode for lowtemperature SOFCs. Several unique features of CELD enable the creation of gas-permeable and percolated SDC layers, showing simultaneous contact between a Pt electrode and YSZ electrolyte. This nano-architectured structure with SDC coatings extends the ORR reaction sites from Pt|YSZ|air to Pt|SDC|air, substantially increasing the number density of the TPBs and thereby the electrode conductance by more than two orders of magnitude compared with that of bare Pt. Furthermore, the enhanced Pt-SDC interactions provide outstanding thermal stability, maintaining higher electrode conductance even at 600 °C without any degradation for more than 100 h. In sum, the CELD method, as described here, is suggested a possible solution to achieve thin-film based cathodes capable of both high performance and long-term stability, key prerequisites for the practical development of LT-SOFCs.

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## Notes and references

- 1 N. Q. Minh, J. Am. Ceram. Soc., 1993, 76, 563-588.
- 2 E. D. Wachsman and K. T. Lee, Science, 2011, 334, 935-939.
- 3 A. Evans, A. Bieberle-Hutter, J. L. M. Rupp and L. J. Gauckler, *J. Power Sources*, 2009, **194**, 119–129.
- 4 H. L. Tuller, S. J. Litzelman and W. Jung, *Phys. Chem. Chem. Phys.*, 2009, **11**, 3023–3034.
- 5 J. An, J. H. Shim, Y. B. Kim, J. S. Park, W. Lee, T. M. Gur and F. B. Prinz, *MRS Bull.*, 2014, **39**, 798–804.
- 6 J. M. Ralph, A. C. Schoeler and M. Krumpelt, *J. Mater. Sci.*, 2001, **36**, 1161–1172.

- 7 S. J. Litzelman, J. L. Hertz, W. Jung and H. L. Tuller, *Fuel Cells*, 2008, **8**, 294–302.
- 8 N. P. Brandon, S. Skinner and B. C. H. Steele, *Annu. Rev. Mater. Res.*, 2003, **33**, 183–213.
- 9 S. B. Adler, Chem. Rev., 2004, 104, 4791-4843.
- 10 S. Wang, T. Kato, S. Nagata, T. Kaneko, N. Iwashita, T. Honda and M. Dokiya, *Solid State Ionics*, 2002, **152**, 477– 484.
- 11 F. S. Baumann, J. Fleig, G. Cristiani, B. Stuhlhofer, H. U. Habermeier and J. Maier, *J. Electrochem. Soc.*, 2007, 154, B931–B941.
- 12 Y. Abe, M. Kawamura and K. Sasaki, *Jpn. J. Appl. Phys.*, 1999, 38, 2092–2096.
- 13 Y. Abe, M. Kawamura and K. Sasaki, *J. Vac. Sci. Technol., A*, 2000, **18**, 2608–2612.
- 14 P. C. Su, C. C. Chao, J. H. Shim, R. Fasching and F. B. Prinz, *Nano Lett.*, 2008, 8, 2289–2292.
- 15 C. C. Chao, C. M. Hsu, Y. Cui and F. B. Prinz, *ACS Nano*, 2011, 5, 5692–5696.
- 16 U. P. Muecke, D. Beckel, A. Bernard, A. Bieberle-Hutter, S. Graf, A. Infortuna, P. Muller, J. L. M. Rupp, J. Schneider and L. J. Gauckler, *Adv. Funct. Mater.*, 2008, **18**, 3158–3168.
- 17 C. W. Kwon, J. W. Son, J. H. Lee, H. M. Kim, H. W. Lee and K. B. Kim, *Adv. Funct. Mater.*, 2011, 21, 1154–1159.
- 18 C. W. Kwon, J. I. Lee, K. B. Kim, H. W. Lee, J. H. Lee and J. W. Son, *J. Power Sources*, 2012, **210**, 178–183.
- 19 N. Baumann, E. Mutoro and J. Janek, *Solid State Ionics*, 2010, 181, 7–15.
- 20 H. Galinski, T. Ryll, P. Elser, J. L. M. Rupp, A. Bieberle-Huetter and L. J. Gauckler, *Phys. Rev. B: Condens. Matter Mater. Phys.*, 2010, 82, 235415.
- 21 T. Ryll, H. Galinski, L. Schlagenhauf, P. Elser, J. L. M. Rupp,
  A. Bieberle-Hutter and L. J. Gauckler, *Adv. Funct. Mater.*,
  2011, 21, 565–572.
- 22 C. C. Yu, S. Kim, J. D. Baek, Y. Li, P. C. Su and T. S. Kim, ACS Appl. Mater. Interfaces, 2015, 7, 6036–6040.
- 23 X. H. Wang, H. Huang, T. Holme, X. Tian and F. B. Prinz, *J. Power Sources*, 2008, **175**, 75–81.
- 24 I. Chang, S. Ji, J. Park, M. H. Lee and S. W. Cha, *Adv. Energy Mater.*, 2015, 5, 1402251.
- 25 A. Buyukaksoy, V. Petrovsky and F. Dogan, *J. Electrochem. Soc.*, 2013, **160**, F482–F486.
- 26 J. L. Hertz and H. L. Tuller, *J. Electrochem. Soc.*, 2007, 154, B413–B418.
- 27 E. N. Armstrong, K. L. Duncan, D. J. Oh, J. F. Weaver and E. D. Wachsman, *J. Electrochem. Soc.*, 2011, **158**, B492–B499.

- 28 E. N. Armstrong, K. L. Duncan and E. D. Wachsman, J. Electrochem. Soc., 2011, 158, B283–B289.
- 29 C. B. Gopal and S. M. Haile, *J. Mater. Chem. A*, 2014, **2**, 2405–2417.
- 30 N. Ai, K. Chen and S. P. Jiang, *Solid State Ionics*, 2013, 233, 87–94.
- 31 Y. Choi, E. C. Brown, S. M. Haile and W. Jung, *Nano Energy*, 2016, DOI: 10.1016/j.nanoen.2016.03.015.
- 32 W. Jung, J. J. Kim and H. L. Tuller, *J. Power Sources*, 2015, 275, 860–865.
- 33 K. Kamada, N. Enomoto and J. Hojo, *Electrochim. Acta*, 2009, 54, 6996–7000.
- 34 E. C. Brown, Ph. D thesis, Caltech, 2011.
- 35 M. Pourbaix, Atlas of electrochemical equilibiria in aqueous solutions, Pergamon Press Ltd., 1966.
- 36 C. C. Chao, M. Motoyama and F. B. Prinz, *Adv. Energy Mater.*, 2012, **2**, 651–654.
- 37 Y. B. Kim, C. M. Hsu, S. T. Connor, T. M. Gur, Y. Cui and F. B. Prinz, *J. Electrochem. Soc.*, 2010, **157**, B1269–B1274.
- 38 I. Zhitomirsky and A. Petric, Ceram. Int., 2001, 27, 149-155.
- 39 D. R. Lide, *CRC Handbook of Chemistry and Physics*, CRC Press, 87th edn, 2006.
- 40 T. Moeller and H. E. Kremers, *J. Phys. Chem.*, 1944, **48**, 395–406.
- 41 Y.-C. Wu, M.-J. Lee and X. Li, *J. Eur. Ceram. Soc.*, 2015, 35, 4485–4495.
- 42 M. C. Steil, F. Thevenot and M. Kleitz, *J. Electrochem. Soc.*, 1997, **144**, 390–398.
- 43 N. L. Robertson and J. N. Michaels, *J. Electrochem. Soc.*, 1991, 138, 1494–1499.
- 44 A. Mitterdorfer and L. J. Gauckler, *Solid State Ionics*, 1999, 117, 203–217.
- 45 J. Mizusaki, K. Amano, S. Yamauchi and K. Fueki, *Solid State Ionics*, 1987, **22**, 313–322.
- 46 J. Mizusaki, K. Amano, S. Yamauchi and K. Fueki, *Solid State Ionics*, 1987, **22**, 323–330.
- 47 D. Y. Wang and A. S. Nowick, *J. Electrochem. Soc.*, 1979, **126**, 1166–1172.
- 48 D. Y. Wang and A. S. Nowick, *J. Electrochem. Soc.*, 1979, **126**, 1155–1165.
- 49 D. Y. Wang, J. Electrochem. Soc., 1990, 137, 3660-3666.
- 50 D. Y. Wang and A. S. Nowick, *J. Electrochem. Soc.*, 1981, **128**, 55–63.
- 51 Y. Nagai, T. Hirabayashi, K. Dohmae, N. Takagi, T. Minami, H. Shinjoh and S. Matsumoto, *J. Catal.*, 2006, **242**, 103–109.
- 52 A. Steinbach, *Annual Progress Report V. Fuel Cells*, U.S. Department of Energy, 3M Company, 2015.